

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Raffaele Zambrano

Application No.

10/615,961

Filed

July 8, 2003

For

METHOD OF FORMING A CONTACT STRUCTURE AND A

FERROELECTRIC MEMORY DEVICE

Examiner

Tu Tu V. Ho

Art Unit

2818

Date of Notice

of Allowance:

November 29, 2004

Docket No.

856063.720D1

Date

February 28, 2005

Noted 03/25/05

Mail Stop Issue Fee Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

## COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

## Commissioner for Patents:

In the Examiner's comments with the Notice of Allowance mailed November 29, 2004, the Examiner stated that the reason for allowance was the failure of the prior art to teach or suggest features that are recited in claim 1. However, allowed claims 7-19 do not include all of the features of claim 1.